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| Form PTO-1449 (Modified) LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary) | Atty Docket No. | Serial No. |
| | HARAP0166US | 10/556,663 |
| | Applicant: Morito AKIYAMA, et al. | |
| | Filing Date | Group |
| | November 11, 2005 | 2811 |

U.S. PATENT DOCUMENTS

| Examiner Initial | Document Number | Date MM/YYYY | Name | Class | Sub-class | Filing Date if Appropriate |
|------------------|-----------------|--------------|------|-------|-----------|----------------------------|
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FOREIGN PATENT DOCUMENTS

| Examiner Initial | Document Number | Date MM/YYYY | Country | Class | Sub-class | Translation | |
|------------------|-----------------|--------------|---------|-------|-----------|-------------|----|
| | | | | | | Yes | No |
| | | | | | | | |

OTHER ART

| Examiner Initial | Author, Title, Date, Pertinent Pages, etc. |
|------------------|---|
| /DR/ | European Search Report for corresponding Application No. 04733100.4 dated June 13, 2007. |
| /DR/ | Yoshimori S. et al.; "Synthesis and AES analysis of Nb(NbN)-AlN multilayers by off-axial DC magnetron sputtering"; Physica C, North-Holland Publishing, Amsterdam, NL; Vol. 305, No. 3-4; September 1, 1998; pages 281-284; XP004150807; ISSN: 0921-4535. |
| /DR/ | Wang X. et al.; "On the role of laminate architecture in thin film synthesized by ion beam assisted deposition"; Journal of Materials Science Letters, Chapman and Hall Ltd., London, GB; Vol. 19, No. 6; March 15 2000; pages 485-487, XP001005034; ISSN: 0261-8028. |
| /DR/ | Lee Si-Hyung et al.; "Growth of highly c-axis textured AlN films on Mo electrodes for film bulk acoustic wave resonators"; Journal of Vacuum Science and Technology A. Vacuum, Surfaces and Films, American Institute of Physics, New York, NY, USA; Vol. 21, No. 1; January 2003; Pages 1-5; XP012006270; ISSN: 0734-2101. |
| /DR/ | Kobyakov V.P.; "Fabrication, microstructure and properties of chemical vapour deposited AlN/Mo laminated composites"; Journal of Materials Science Chapman & Hall UK; Vol. 32, No. 16; August 15, 1997; Pages 4347-4353; XP002434516; ISSN: 0022-2461. |

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|--------------------------|----------------------------|
| EXAMINER /Derek Rosenau/ | DATE CONSIDERED 10/07/2008 |
|--------------------------|----------------------------|

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Information Disclosure Statement PTO-1449 (Modified)

The identification of any reference is not intended to be, and should not be understood as being, an admission that such publication, in fact, constitutes "prior art" within the meaning of applicable law since, for example, a given reference may have a later effective date than first seems apparent or the reference may have an effective date which can be antedated. The "prior art" status of any reference is a matter to be resolved during prosecution.